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08/05/2008

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicant : Paul D. Shirley  
Serial No. : 10/773,968  
Filed : February 6, 2004  
Title : **DEVICE AND METHOD FOR FORMING IMPROVED RESIST LAYER**  
Docket : MIO 0112 PA/40509.272  
Examiner : Laura E. Edwards  
Art Unit : 1792  
Conf. No. : 7341

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

EFS Web Electronic Submission

July 30, 2008

Sir:

**RESPONSE UNDER 37 CFR 1.116**

This paper is being filed in response to the Office Action mailed on June 27, 2008. Reconsideration of the present application is respectfully requested in light of the remarks below.